NANOGROUP INSTRUMENTATION

If you have <u>troubles</u> with a machine or an alarm signal appears, contact <u>immediately</u> Sabrina Eder (+47 94 20 4733) or Martin M. Greve (+47 900 79 974)

1) Nanolab and clean room

Nanolab lab-space:

- Clean room spaces and chemical lab-space
 - $\circ~$ to access the Nanolab lab-spaces one requires an introduction and basic training by UiB personnel.
 - Access and training contact personnel UiB:
 - Martin M. Greve: +47 900 79 974 <u>martin.greve@uib.no</u>
 - Sabrina Eder: +47 94 20 4733 <u>sabrina.eder@uib.no</u>
 - the basic introduction and training includes a read through, discussion and signing of the 'Rules and basics for the Nano-laboratory' document.
 - $\circ~$ Access to the Nanolab laboratory is ABSOLUTELY forbidden without this introduction!
 - Online file: Basics for the laboratory_External (wiki page) ✓

E-line room:

- > Raith e-line: Electron-beam lithography & microscopy
 - the instrument requires an introduction and basic training by UiB personnel.
 - to book the equipment, use the instrument specific e-line google calendar which you will be added too once you received the introduction and basic training for the instrument.
 - \circ Online files:
 - SOP imaging: Raith_imaging SOP_2023(wiki page) ✓✓
 - SOP e-beam lithography: SOP_Raith_E-Line_2023 (wiki page) ✓✓
- Sputter coater: EMITECH SC7620 Mini Sputter Coater
 - \circ $\;$ the instrument requires an introduction and basic training by UiB personnel.
 - $\circ \;\;$ currently booking of the instrument is not required.
 - Online file: SOP_Mini Sputter Coater_2023 (wiki page) ✓✓

Semi-clean room:

- > Temescal FC-2000: Electron-beam evaporator
 - the instrument requires an introduction and basic training by UiB personnel.
 - to book the equipment, use the instrument specific Temescal google calendar which you will be added too once you received the introduction and basic training for the instrument.
 - \circ Online files:
 - SOP file: SOP_Temescal_EbeamEvaporator_2023 (wiki page) ✓✓
 - Maintenance: SOP_Temescal_EbeamEvaporator_Maintenance_2023 ✓✓
- > Nikon ECLIPSE LV100ND: Optical microscope

- \circ $\;$ the instrument requires an introduction by UiB personnel.
- $\circ~$ currently booking of the instrument is not required.
- Online files:
 - SOP file: SOP_Nikon_LV_1000_2023 (wiki page) ✓✓
 - Manual: Nikon LV-100D-U Manual (too big for wiki page) ✓
- Nikon SMZ 1500: Stereo microscope
 - o the instrument requires an introduction by UiB personnel.
 - currently booking of the instrument is not required.
 - Online file: SOP_Nikon_SMZ 1500_Stereomicroscope_2023 (wiki page) ✓✓
- Contact Angle System: dataphysics OCA 20L
 - \circ $\;$ the instrument requires an introduction and basic training by UiB personnel.
 - currently booking of the instrument is not required.
 - \circ Online files:
 - SOP file: SOP_Contact Angle_2023 (wiki page) ✓✓
 - Manual: OCA_206_E (too big for wiki page) ✓
- Mask Aligner: Manual High End Mask Aligner MJB4 (SÜSS MicroTec)
 - the instrument requires an introduction and basic training by UiB personnel.
 - currently booking of the instrument is not required.
 - Online files:
 - SOP file: SOP_Mask Aligner_2023 (wiki page) ✓✓
 - Manual: Karl Suss MJB-4 manual (too big for wiki page) ✓
- Fume hood, hot plates, ultrasonic cleaner:
 - $\circ~$ an introduction and basic training by UiB personnel is given during the general chemical lab-space introduction.
 - o booking is not required but training with lab introduction is requirement.
 - SOP file: Basics for the laboratory_External (wiki page) ✓

<u>Clean room:</u>

- Plasmatherm 790+: Reactive-ion etcher
 - the instrument requires an introduction and basic training by UiB personnel.
 - to book the equipment, use the instrument specific Plasmatherm google calendar which you will be added too once you received the introduction and basic training for the instrument.
 - \circ Online file:
 - SOP file: SOP_Plasmatherm_790Plus_2023 (wiki page) ✓✓
 - Maintenance: SOP_Plasmatherm_790Plus_Maintenance_2023 ✓✓
- Filmetrics F-10: Thin-film characterisation
 - \circ $\;$ the instrument requires an introduction and basic training by UiB personnel.
 - currently booking of the instrument is not required.
 - Online file: SOP_Filmetrics_2023 (wiki page) ✓
- Spin-coater: Laurell WS-400BX-6NPP/LITE (SN 08839)
 - \circ $\;$ the instrument requires an introduction by UiB personnel.
 - $\circ~$ currently booking of the instrument is not required.
 - \circ Online file:

- SOP file: SOP_Laurell WS 400BX Spin coater_2023 (wiki page) ✓✓
- Manual: LITE_Manual_WE-400BX_Spin coater (wiki page)
- > UV-lithography setup:
 - \circ $\;$ the instrument requires an introduction by UiB personnel.
 - currently booking of the instrument is not required.
 - \circ No manual
- ➢ Fume hood, hot plates, ultrasonic cleaner:
 - an introduction and basic training by UiB personnel is given during the general chemical lab-space introduction.
 - booking is not required but training with lab introduction is requirement.
 - SOP file: Basics for the laboratory_External (wiki page) ✓

2) Bond lab

<u>Room 267:</u>

- ➢ Fluorination chamber: SPTS XETCH
 - the instrument requires an introduction and basic training by qualified personnel.
 - NOTE: dangerous gases are used in this instrument!
 - $\circ~$ currently booking of the instrument is not required.
 - \circ Online files:
 - SOP file: SOP_XetchX3_Fluorination chamber_2023 (wiki page) ✓✓
 - Manual: Xactic-XetchX3-System-Manual (wiki page) ✓✓

3) Measurement Lab

<u>Room 263:</u>

- Jupiter AFM: Oxford Instrument Asylumn Research
 - the instrument requires an introduction and basic training by UiB personnel.
 - to book the equipment, use the instrument specific AFM google calendar which you will be added too once you received the introduction and basic training for the instrument.
 - Online files:
 - SOP file: SOP file: SOP_Jupiter AFM_2023 (wiki page) ✓✓
 - Manuals: (too big for wiki page) ✓
 - User guide: AR Jupiter User Guide_19C ✓
 - Application guide: AR Applications Guide_19C ✓

4) Meta Lab

<u>Room 270B:</u>

- Meta: Metastable-helium lithography
 - the instrument requires an introduction and basic training by qualified personnel.
 - $\circ~$ currently booking of the instrument is not required.
 - $\circ \quad \text{No manual} \quad$

5) Magie & Nemi Lab

<u>Room 191:</u>

- > Magie: Neutral atom scattering instrument
 - the instrument requires an intensive training by UiB personnel.
 - currently booking of the instrument is not required.
 - $\circ \quad \text{No manual} \quad$
- > Nemi: Neutral helium microscope
 - \circ $\;$ the instrument requires an intensive training by UiB personnel.
 - o currently booking of the instrument is not required.
 - $\circ \quad \text{No manual} \quad$